

(12) NACH DEM VERTRAG ÜBER DIE INTERNATIONALE ZUSAMMENARBEIT AUF DEM GEBIET DES
PATENTWESENS (PCT) VERÖFFENTLICHTE INTERNATIONALE ANMELDUNG

(19) Weltorganisation für geistiges Eigentum
Internationales Büro



(43) Internationales Veröffentlichungsdatum
30. September 2004 (30.09.2004)

PCT

(10) Internationale Veröffentlichungsnummer
WO 2004/083786 A2

(51) Internationale Patentklassifikation⁷: **G01F**

[DK/DK]; Nydamvej 62, Øster Sottrup, Sønderborg, 6400 (DK).

(21) Internationales Aktenzeichen: PCT/EP2004/003019

(22) Internationales Anmeldedatum:
22. März 2004 (22.03.2004)

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(25) Einreichungssprache: Deutsch

(26) Veröffentlichungssprache: Deutsch

(30) Angaben zur Priorität:
103 12 824.7 22. März 2003 (22.03.2003) DE

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(81) Bestimmungsstaaten (soweit nicht anders angegeben, für jede verfügbare nationale Schutzrechtsart): AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BW, BY, BZ, CA, CH, CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, EG, ES, FI, GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ, NA, NI, NO, NZ, OM, PG, PH, PL, PT, RO, RU, SC, SD, SE, SG, SK, SL, SY, TJ, TM, TN, TR, TT, TZ, UA, UG, US, UZ, VC, VN, YU, ZA, ZM, ZW.

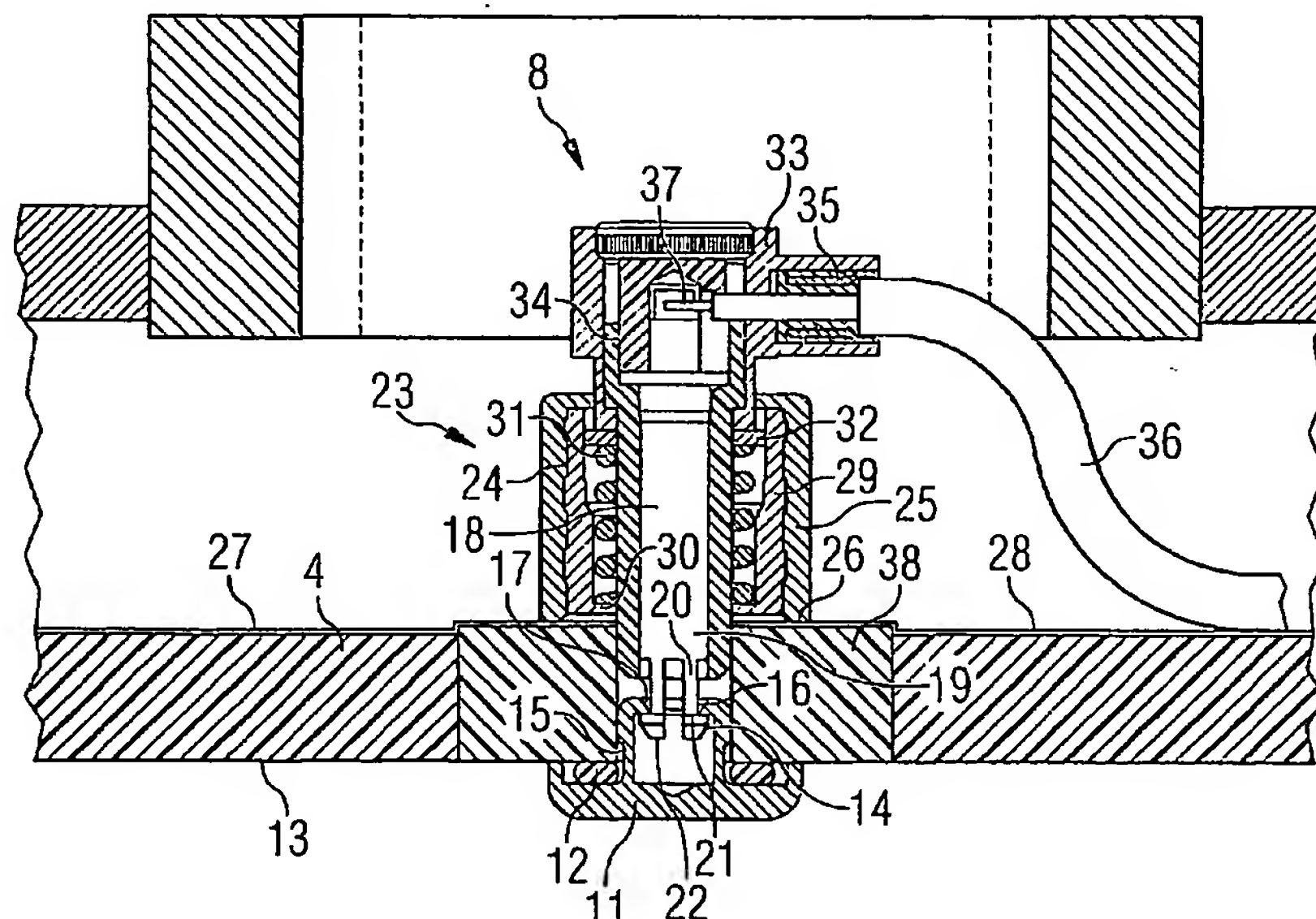
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[Fortsetzung auf der nächsten Seite]

(54) Title: **MAGNETIC INDUCTIVE FLOWMETER**

(54) Bezeichnung: **MAGNETISCH-INDUKTIVER DURCHFLUSSMESSER**



(57) Abstract: The invention relates to a magnetic inductive flowmeter comprising: a measuring distance that is surrounded by a wall (4); a magnetic field generating device, and; an electrode device (8), which has at least one electrode (11) on the inside (13) of the wall (4) and an electrode connection (18) on the outside (27) of the wall (4). The aim of the invention is to simplify the assembly of the inventive flowmeter. To this end, the electrode connection (18) is connected to the electrode (11) by means of a plug-type connection, and the electrode connection (18) fixes the electrode (11) to the wall (4).

[Fortsetzung auf der nächsten Seite]

WO 2004/083786 A2



(84) Bestimmungsstaaten (soweit nicht anders angegeben, für jede verfügbare regionale Schutzrechtsart): ARIPO (BW, GH, GM, KE, LS, MW, MZ, SD, SL, SZ, TZ, UG, ZM, ZW), eurasisches (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), europäisches (AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, HU, IE, IT, LU, MC, NL, PL, PT, RO, SE, SI, SK, TR), OAPI (BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR, NE, SN, TD, TG).

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(57) Zusammenfassung: Es wird ein magnetisch-induktiver Durchflussmesser angegeben mit einer Messstrecke, die von einer Wand (4) umgeben ist, einer Magnetfelderzeugungseinrichtung und einer Elektrodenanordnung (8), die mindestens eine Elektrode (11) auf der Innenseite (13) der Wand (4) und einen Elektrodenanschluss (18) auf der Außenseite (27) der Wand (4) aufweist. Man möchte die Montage vereinfachen. Hierzu ist vorgesehen, dass der Elektrodenanschluss (18) über eine Steckverbindung mit der Elektrode (11) verbunden ist und der Elektrodenanschluss (18) die Elektrode (11) an der Wand (4) fixiert.

Description

Magnetic inductive flowmeter

5 The invention relates to a magnetic inductive flowmeter comprising a measuring distance that is surrounded by a wall, a magnetic field generating device and an electrode device, which has at least one electrode on the inside of the wall and an electrode connection on the outside of the wall.

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A flowmeter of this type is known, for example, from US 4 297 897. The measuring distance is normally formed by a tube. Two magnetic coils that generate a flow through the tube perpendicular to the direction of flow are disposed on the outside of the tube. Electrodes that have contact with the fluid are arranged at approximately 90° to the magnetic coils. A voltage between the two electrodes is dependent both on the strength of the magnetic field and on the speed of the fluid flowing through.

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In the known case, the electrode is screwed into an inner thread of a fitting that is inserted through the wall of the tube. The fitting in turn has an outer thread onto which a nut is threaded. The fitting has an enlarged head on the inside of the wall, so that the wall is clamped between the head and the nut when a washer and a spring are interposed.

A further electrode array for a magnetic inductive flowmeter is known from EP 1 217 338 A2, in which the electrode has a shaft, which is routed through the wall of the measuring tube. The shaft has an outer thread onto which a nut is threaded in order to tighten the electrode to the wall.

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The assembly cost is relatively high in such an embodiment. At least one, but in most cases several, screw connections are needed in order to fix the electrode in the wall of the measuring distance and in order to connect an electrical cable.

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The object of the invention is to simplify the assembly.

This object is achieved by means of a flowmeter of the type described above, in which the electrode connection is connected to the electrode via a plug-type connection and the electrode connection fixes the electrode to the wall.

This embodiment has a number of advantages. The assembly is considerably simplified. Screw connections no longer have to be provided between the electrode connection and the electrode. This means that the assembly of the electrode array can be effected largely independently of the person who carries out the assembly. For example, it is not possible for excessive restraining moments to occur. The results of the assembly can therefore be reproduced more readily.

The plug-type connection is preferably configured inside the wall. The advantage of this is, firstly, that the electrode per se can be kept relatively small. It no longer needs to be inserted through the wall, but may terminate in the wall by means of an extension. This design is particularly effective in reducing costs if special and therefore expensive materials need to be used for the measurement in a special fluid, because only very little of the expensive material is required. The electrode connection may be formed from a different material because it is no longer in contact with the fluid. In addition, the plug-type connection is protected. Both the electrode and the electrode connection project into the wall, hence are at

least partially routed. This makes the connection more stable.

The electrode connection is preferably surrounded, at least outside the wall, by a metallic shield. The electrode
5 connection therefore has, so to speak, a protective housing that forms a Faraday cage. This is effective in suppressing spurious radiation from electrical or magnetic fields. This is particularly advantageous in a flowmeter in which the signal
10 voltages that indicate the speed of the fluid flowing through are relatively small. It is possible, for example, for a shielded cable to be fed into a metallic shield of this type, said cable then being connected to the electrode connection inside the metallic shield. This connection may be
15 prefabricated. The final assembly of the electrode in the wall is then easily effected by inserting the electrode into the wall from one side and inserting the electrode connection with its protective housing from the other side. When the plug-type connection is established between the electrode and the
20 electrode connection, the electrode is then firmly held in the wall and the electrode connection is shielded.

The electrode preferably has one part of a barb connection, which holds it in position. This makes it possible to increase the forces with which the electrode is held in the wall, over
25 and above simple frictional locking between the electrode and the electrode connection. A barb connection has an edge at the end of a conical surface that can interconnect to a mating component. For example, the edge can be pushed into the material that forms the wall.

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The barb connection is preferably configured between the electrode and the electrode connection. This means that the wall is not burdened by the connection. In the event of a

malfunction, it is possible simply to disconnect the connection and use a new electrode and electrode connection pairing, which can then once again securely form a barb connection because there are no corresponding impressions in the wall of the housing.

In this context it is particularly preferable for the barb connection to be designed as a snap connection in which a first connection element, which is designed as a spring, is locked into place behind a second connection element. A snap connection of this type permits positive locking, which enables far greater retaining forces to be used than a simple frictional lock even if the latter is reinforced by a sharp edge.

The first connection element is preferably configured as a ring with interruptions, which is surrounded by an annular spring. This ring has an inwardly projecting circumferential flange or - in any case - parts that project inward radially, which may be beveled on their upper surface. The annular spring, for example an elastic ring, allows the individual ring sections to be contorted outward radially when the connection is established. However, the sections are then pushed back again by the annular spring when the second connection element is locked in place.

The second connection element is preferably supported on the wall of a cylindrical hole. In this case, it is useful if the first connection element can be sprung radially inward. If the second connection element is supported on the wall of the cylindrical hole, this provides a further retention option so that the positioning of the electrode array in the wall is further improved.

In this context it is preferable for the second connection element to be configured on the electrode. The electrode is not contorted when the snap connection is established. This means, therefore, that there will be no concerns subsequently about malfunctions being caused by the electrode possibly being unintentionally contorted.

Preferably, a spring arrangement that stresses the electrode connection in a direction away from the electrode, acts upon the electrode connection. In this way the electrode is securely pulled against the inside of the wall. If a washer is provided between the electrode and the wall, then the forces of the spring arrangement have the effect of compressing said washer, thus improving the sealing efficiency. Particularly with regard to a snap connection, the retaining forces in the connection between the electrode and the electrode connection are increased. It is virtually impossible to accidentally loosen a snap connection under voltage.

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In this context it is particularly preferable for the spring arrangement to act upon the shield and to push it against the outside of the wall. This provides a virtually interruption-free shield. The outside of the wall is provided with many layers of shielding foil, for example a copper foil. The spring arrangement therefore creates sufficient contact force between the shield and the shielding foil.

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In this context it is preferable for the shield with a ring surface to be located outside the spring arrangement on the outside of the wall. The ring surface is relatively narrow and therefore small. This enables a relatively large amount of pressure to be achieved between the shield and the foil on the

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outside of the wall.

It is also advantageous if the electrode connection is in one piece and is connected directly to a signal conductor. This connection may be formed either by the signal conductor being extended in the electrode connection, or by the signal conductor being soldered, welded or glued to the electrode connection, or fastened to it by similar means. Subsequent fastening stages may be dispensed with. The electrical contact is improved.

The invention is described in greater detail below on the basis of preferred exemplary embodiments together with the drawings. In these,

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Fig.1 is a schematic diagram of a magnetic inductive flowmeter,

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Fig. 2 is a first embodiment of an electrode array,

Fig. 3 is a second embodiment of an electrode array,

Fig. 4 is a third embodiment of an electrode array, and

25 Fig. 5 is a fourth embodiment of an electrode array.

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Fig.1 shows a magnetic inductive flowmeter 1 with a measuring distance 2, through which a fluid may flow perpendicular to the plane of projection. The measuring distance is configured in the interior of a tube 3 with a wall 4. Two coils 5, 6 are connected to a power supply 7. When the coils 5, 6 are supplied with power, they generate a magnetic field that is oriented perpendicular to the direction of flow. Two electrode arrays 8,

9 are connected to an analysis device 10. When the coils 5, 6 generate a magnetic field and a fluid flows through the tube 3 perpendicular to the plane of projection, a voltage is created between the electrodes 8, 9. This voltage can be evaluated by the analysis device 10 and enables the mass flow of the fluid to be indicated.

Fig. 2 now shows such an electrode array 8 in greater detail.

10 The electrode array 8 has an electrode 11 which is arranged on the inside 13 of the wall 4 with a washer 12 interposed. The electrode 11 has an extension 14, which is plugged into an aperture 15 in the wall 4. The radial exterior of the extension 14 rests against the wall of the cylindrical hole 15. The end
15 of the extension is shaped radially inward, so that a circumferential projection 16 is formed that has a beveled upper surface 17. The projection 16 thus forms an inner cone.

The lower end 19 of an electrode connection 18 is likewise
20 inserted into the cylindrical hole 15. The electrode connection 18 has sprung fingers 20 at its end, said sprung fingers terminating in projections 21 that point outward radially. The projections 21 have a beveled end face 22.

25 The projections 21 of the electrode connection 18 grasp the projection 16 of the extension 14 of the electrode 11. This forms a snap connection between the electrode 11 and the electrode connection 18.

30 The electrode connection 18 has a shield 23 with a housing 24. The housing 24 has an outer ring 25, the end face 26 of which is disposed on the outside 27 of the wall 4. A copper foil 28 is laminated on the outside 27. Contact between the outer ring

25 and the copper foil 28 creates an electrically conductive connection between the housing 24 and the copper foil 28.

The housing 24 also has an inner ring 29, which is pressed into
5 the outer ring 25. On the end of the inner ring 29 adjacent to the wall 4, there is an inward projection 30 on which a spring 31 is supported. The spring 31 acts upon a head 33 via a disk 32, said head 33 in turn acting on the upper end of the electrode connection 18 and thus forcing the electrode
10 connection 18 away from the electrode 11. An insulating device 34 is disposed between the head 33 and the electrode connection 18, said insulating device extending into the cylindrical hole 15.

15 In the exemplary embodiment, the head 33 is shown to have a circumferential, inward projection in the area of the disk 32, said projection acting upon a step in the insulating device 34. The insulating device 34 has an enlarged diameter on which rests a corresponding enlarged diameter of the electrode
20 connection. Fundamentally, all contact surfaces need only be capable of being subjected to pressure. Other embodiments are, however, clearly possible.

The head 33 is connected to a shield 35 of a shielded cable 36.
25 The shielded cable 36 has a core 37 that is connected to the electrode connection 18, for example by soldering.

The upper end of the housing 24 encloses the head 33 as tightly as possible. However, a telescopic movement of the head 33
30 against the force of the spring 31 is still permitted in the housing 24.

The electrode connection 18, together with the housing 24, the

spring 31, the head 33 and the cable 36 may be preassembled, for example by automatic handling devices.

To effect assembly of the electrode 11, the electrode 11 is
5 inserted into the cylindrical hole 15 in the wall 4 from the inside 13. Since the electrode 11 is arranged with the outside of the extension 14 on the wall of the cylindrical hole 15, this produces a gentle frictional lock that ensures that the electrode 11 cannot fall out of the cylindrical hole 15.

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The electrode connection 18 is inserted into the cylindrical hole from the opposite side, with the head 33 being pushed toward the electrode 11. If the end face 22 of the projections 21 on the fingers 20 then comes to rest on the upper end 17 of
15 the extension 14, the fingers 20 are pushed radially inward such that the projections 21 on the end of the fingers 20 can adapt to the projection 16 on the extension 14. As soon as they have been moved past the extension 14, they spring back outward radially and become firmly hooked behind the projection 16 of
20 the extension 14. If the head 33 is not then being pushed further against the force of the spring 31 toward the electrode 11, then the spring 31 can expand and pushes the electrode connection 18 away from the electrode 11 so that the projections 21 on the fingers 20 hook behind the projection 16
25 on the extension 14. This results initially in a positively locked connection between the electrode 11 and the electrode connection 18. The projections 21 are arranged in this connection with a force on the projection 16 that is sufficient to establish an electrical contact with the requisite degree of
30 reliability.

At the same time the washer 12, as shown, is compressed so that the electrode 11 is also retained in the wall 4, with a fluid-

tight seal.

The connection between the electrode 11 and the electrode connection 18 is effected in the middle of the wall 4. For this purpose the wall 4 may have a section 38 that is slightly thicker. The section 38 may be designed to be level on the outside 27, so that the end face 26 of the outer ring 25 may also be designed to be level. It is therefore not necessary to observe any specific orientation when the electrode connection 18 is inserted into the electrode 11.

The embodiment in Fig. 3 essentially corresponds to the embodiment in Fig. 2. The same components are therefore labeled with the same reference numbers. Unlike in the configuration according to Fig. 2, in the configuration according to Fig. 3 the electrode is provided with an extension 14, which has slots 39, permitting the formation of legs 40 that can spring outward. These legs 40 are retained inward radially by an annular spring 41, for example an elastic ring.

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On the end of the legs 40 there is a beveled head 42, which also protrudes radially inward over the legs 40. A mating component 43 on the electrode connection 18 may then become hooked behind the heads 42 on the legs 40. A snap connection can also be established in this way.

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Fig. 4 shows an embodiment in which a snap connection has been established between the electrode 11 and the electrode connection 18 in practically the same way as in Fig. 2. However, in this case a spring 44 is still disposed between the housing 24 and the wall 4. This is a disk spring so that electrical shielding is also present in the area between the housing 24 and the wall 4.

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In the embodiment according to Fig. 5, there is a simple plug connection between the electrode 11 and the electrode connection 18. The electrode 11 may have a sleeve extension 45 for this purpose, into which the electrode connection 18 is inserted, thus resulting in a relatively long contact surface.

The housing 24 is connected to the copper foil 28 via a soldered connection.

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The extension 14 has a projection 47 that protrudes outward radially, the maximum outer diameter of said projection being slightly larger than the inner diameter of the cylindrical hole 15. When the electrode 11 is pushed into the cylindrical hole 15, the projection 47 "bites" firmly into the wall 4. In this embodiment the electrode is retained in the wall 4 by the projection 47. The housing 24 is positioned via the solder connection 46. For this reason the frictional locking of the plug connection between the electrode connection 18 and the sleeve extension 45 is sufficient.

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Claims

1. Magnetic inductive flowmeter comprising a measuring distance that is surrounded by a wall, a magnetic field generating device and an electrode device, which has at least one electrode on the inside of the wall and an electrode connection on the outside of the wall,
characterized in that the electrode connection (18) is connected to the electrode (11) via a plug-type connection and the electrode connection (18) fixes the electrode (11) to the wall (4).
2. Flowmeter according to Claim 1, characterized in that the plug-type connection is configured inside the wall (4).
3. Flowmeter according to Claim 1 or 2, characterized in that the electrode connection (18) is surrounded, at least outside the wall (4), by a metallic shield (23).
4. Flowmeter according to one of Claims 1 to 3, characterized in that the electrode (11) has one part (16, 42, 47) of a barb connection, which holds it in position.
5. Flowmeter according to Claim 4, characterized in that the barb connection is configured between the electrode (11) and the electrode connection (18).
6. Flowmeter according to Claim 5, characterized in that the barb connection is designed as a snap connection (16, 21; 22, 43), in which a first connection element (21, 42), which is designed as a spring, is locked into place behind a second connection element (16, 43).

7. Flowmeter according to Claim 6, characterized in that the first connection element (42) is configured as a ring with interruptions (3), which is surrounded by an annular spring (41).

5

8. Flowmeter according to Claim 6, characterized in that the second connection element (16) is supported on the wall of a cylindrical hole.

10 9. Flowmeter according to Claim 8, characterized in that the second connection element (16) is configured on the electrode (11).

15 10. Flowmeter according to one of Claims 5 to 9, characterized in that a spring arrangement (31, 44) that stresses the electrode connection (18) in a direction away from the electrode (11), acts upon the electrode connection (18).

20 11. Flowmeter according to Claim 10, characterized in that the spring arrangement (31) acts upon the shield (23) and pushes it against the outside (27) of the wall (4).

25 12. Flowmeter according to Claim 10 or 11, characterized in that the shield (23) with a ring surface (26) is located outside the spring arrangement (31) on the outside (27) of the wall (4).

30 13. Flowmeter according to one of Claims 1 to 12, characterized in that the electrode connection is in one piece and is connected directly to a signal conductor.

INTERNATIONAL SEARCH REPORT

International Application No
EP1/EP2004/003019

A. CLASSIFICATION OF SUBJECT MATTER
IPC 7 G01F1/58

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)
IPC 7 G01F

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the International search (name of data base and, where practical, search terms used)

EPO-Internal, WPI Data, PAJ

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category *	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X	PATENT ABSTRACTS OF JAPAN vol. 0185, no. 67 (P-1820), 28 October 1994 (1994-10-28) & JP 6 207841 A (YAMATAKE HONEYWELL CO LTD), 26 July 1994 (1994-07-26) abstract; figure 1	1-3,13
X	PATENT ABSTRACTS OF JAPAN vol. 1997, no. 02, 28 February 1997 (1997-02-28) & JP 8 254450 A (YAMATAKE HONEYWELL CO LTD), 1 October 1996 (1996-10-01) abstract; figures 1,3,4	1-3,13
A	US 4 297 897 A (YOUNG) 3 November 1981 (1981-11-03) cited in the application figure 3	1,4
-/-		

☒ Further documents are listed in the continuation of box C.

☒ Patent family members are listed in annex.

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Date of the actual completion of the international search

7 October 2004

Date of mailing of the international search report

18/10/2004

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INTERNATIONAL SEARCH REPORT

International Application No
PCT/EP2004/003019

C.(Continuation) DOCUMENTS CONSIDERED TO BE RELEVANT

Category *	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
A -	<p>US 5 400 659 A (YOKOI ET AL) 28 March 1995 (1995-03-28) abstract; figure 2 column 1, line 33 - line 44 -----</p>	3

INTERNATIONAL SEARCH REPORT

Information on patent family members

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